

VIA EFS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of:		§	
Takashi ITO, et al.		§	
		§	
Conf. No.:	8148	§	Group Art Unit: 1795
		§	
Appln. No.:	10/562,098	§	Examiner: Anca Eoff
		§	
Filing Date:	December 21, 2005	§	Attorney Docket No.: 9369-114US
		§	(T37-196236C)
Title:	ACTINIC RADIATION-CURABLE STEREOLITHOGRAPHIC RESIN COMPOSITION HAVING IMPROVED STABILITY		

PETITION FOR EXTENSION OF TIME UNDER (37 C.F.R. § 1.136(a))

Applicant(s) in the above-identified application hereby petition(s) for a two-month extension of time to and including January 11, 2011 for responding to the Office Action mailed August 11, 2010. A Request for Reconsideration accompanies this Petition.

☐ A check in the amount of \$__.00 is enclosed herewith.

☒ The Commissioner is hereby authorized to charge Deposit Account No. 50-1017 (**Billing No. 209369.0114**) as noted below.

☒ Extension fee in the amount of \$490.00

☒ Any deficiencies or overpayments in the above-calculated fee.

Respectfully submitted,
Takashi Ito, et al.

January 10, 2011	By: /Sandra M. Katz/
(Date)	SANDRA M. KATZ
	Registration No. 51,864
	PANITCH SCHWARZE BELISARIO & NADEL LLP
	One Commerce Square
	2005 Market Street, Suite 2200
	Philadelphia, PA 19103-7013
	Telephone: 215-965-1330
	Direct Dial: 215-965-1344
	Facsimile: 215-965-1331
	E-Mail: skatz@panitchlaw.com

SMK/rdB